

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:	:	Group Art Unit:
Crawford, et. al.	:	Intellectual Property Law Department
Serial No.:	:	International Business
Filed: <i>Herewith 11/21/03</i>	:	Machines Corporation
Title: System and Method for Process	:	Software Group IP Law -- T81/503
Driven Quality Measures	:	3039 Cornwallis Road
	:	Research Triangle Park, NC 27709

INFORMATION DISCLOSURE STATEMENT

The Assistant Commissioner of Patents
Washington, D.C. 20231

Sir:

Applicants submit herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.


While this Information Disclosure Statement may be "material" pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to herein is "prior art" for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97(g) the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR § 1.56 (a) exists.

The attached form, PTO-1449, provides a listing of patents, publications, or other information as required by 37 CFR § 1.98 (a)(1).

A copy of each of the items on PTO-1449 is supplied herewith.

Respectfully submitted,

By 
Joseph T. Van Leeuwen
Attorney for Applicant
Registration No. 44,383
Telephone: (512) 301-6738
Facsimile: (512) 301-6742

In Place of FORM PTO-1449 (Modified)

Serial No. _____

Applicant: Crawford, et. al.

Filing Date: _____

Group: _____

Atty. Docket No. RSW920030203US1**LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE
STATEMENT****U. S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
/MAF/	AA 2003/0018511	Jan 23, 2003	Bicknell et al.	705	9	
/MAF/	AB 6,535,775	Mar 18, 2003	Bagepalli et al.	700	109	
/MAF/	AC 2003/0135399	Jul 17, 2003	Ahamparam et al.	705	7	
/MAF/	AD 2002/0165765	Nov 7, 2002	Sommerfeld et al.	705	14	
/MAF/	AE 5,278,751	Jan 11, 1994	Adiano et al.	364	402	
_____	AF					
_____	AG					
_____	AH					
_____	AI					
_____	AJ					
_____	AK					
_____	AL					

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
_____	AM 11,288,427	Oct 19, 1999	Japan	G06F	17/50	No
_____	AN					
_____	AO					
_____	AP					

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
/MAF/	AQ Vouk, "Software Reliability Engineering," 2000 Annual Reliability and Maintainability Symposium, 2000.					
_____	AR					
_____	AS					
_____	AT					

Examiner: /Mark Fleischer/

Date Considered: 03/10/2008

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.